



SEP 14 2006

<p>Substitute for form 1449A/PTO</p> <p><b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b></p> <p>(use as many sheets as necessary)</p>				<p><i>SEARCHED &amp; SERIALIZED MAY 2004</i></p> <p><b>Complete If Known</b></p>	
Sheet	1	of	2	Application Number	10/815,398
				Filing Date	March 31, 2004
				First Named Inventor	Wang Yueh
				Art Unit	1752
				Examiner Name	Not yet assigned
				Attorney Docket Number	42P18694

U.S. PATENT DOCUMENTS

## **FOREIGN PATENT DOCUMENTS**

Examiner Signature	J. J. J. J. J.	Date Considered	1-9-05
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\*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication.

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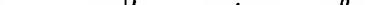
Based on PTO/SB/08A (08-03) as modified by Blakely, Solokoff, Taylor & Zalman (wtr) 08/11/2003.

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Sheet	2	of	2		

## **NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No'	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T*
SJL		Takechi, Satoshi, et al., "Impact of 2-Methyl-2-Adamantyl Group Used for 193-nm Single Layer Resist", Journal of Photopolymer Science and Technology, Vol. 9, No. 3 (1996) Pgs. 475-488.	
		Koji Nozaki, et al. and Akiko Kotachi et al., "A Novel Polymer for A 193-nm Resist", Journal of Photopolymer Science and Technology, Vol. 9, No. 3 (1996) Pgs. 509-522.	

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